

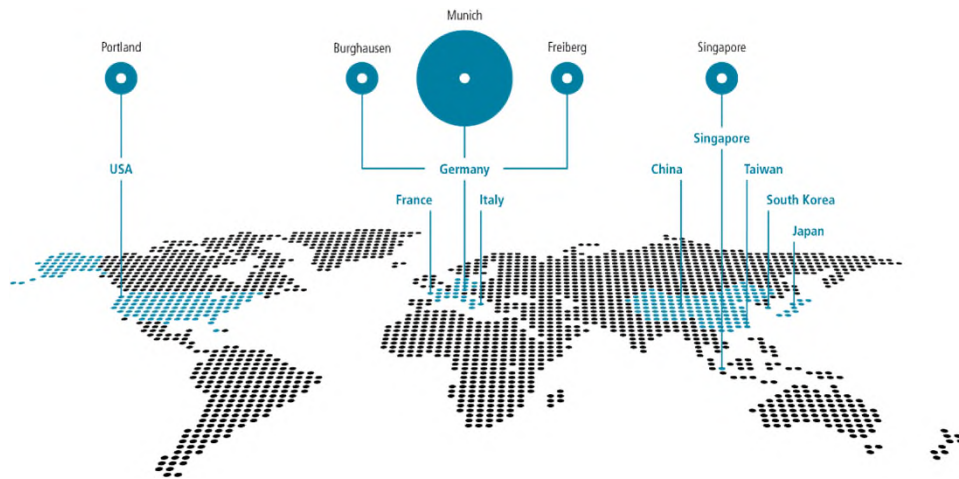
Data cockpit: Ways to extend a master table on click with additional data

Georg Raming, Siltronic AG

[JMP Discovery Summit Europe](#)

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Siltronic at a glance



4 world-class production sites



~ 4,500 employees



global scale and reach



50+ years of history in silicon technologies

Key financial figures 2022

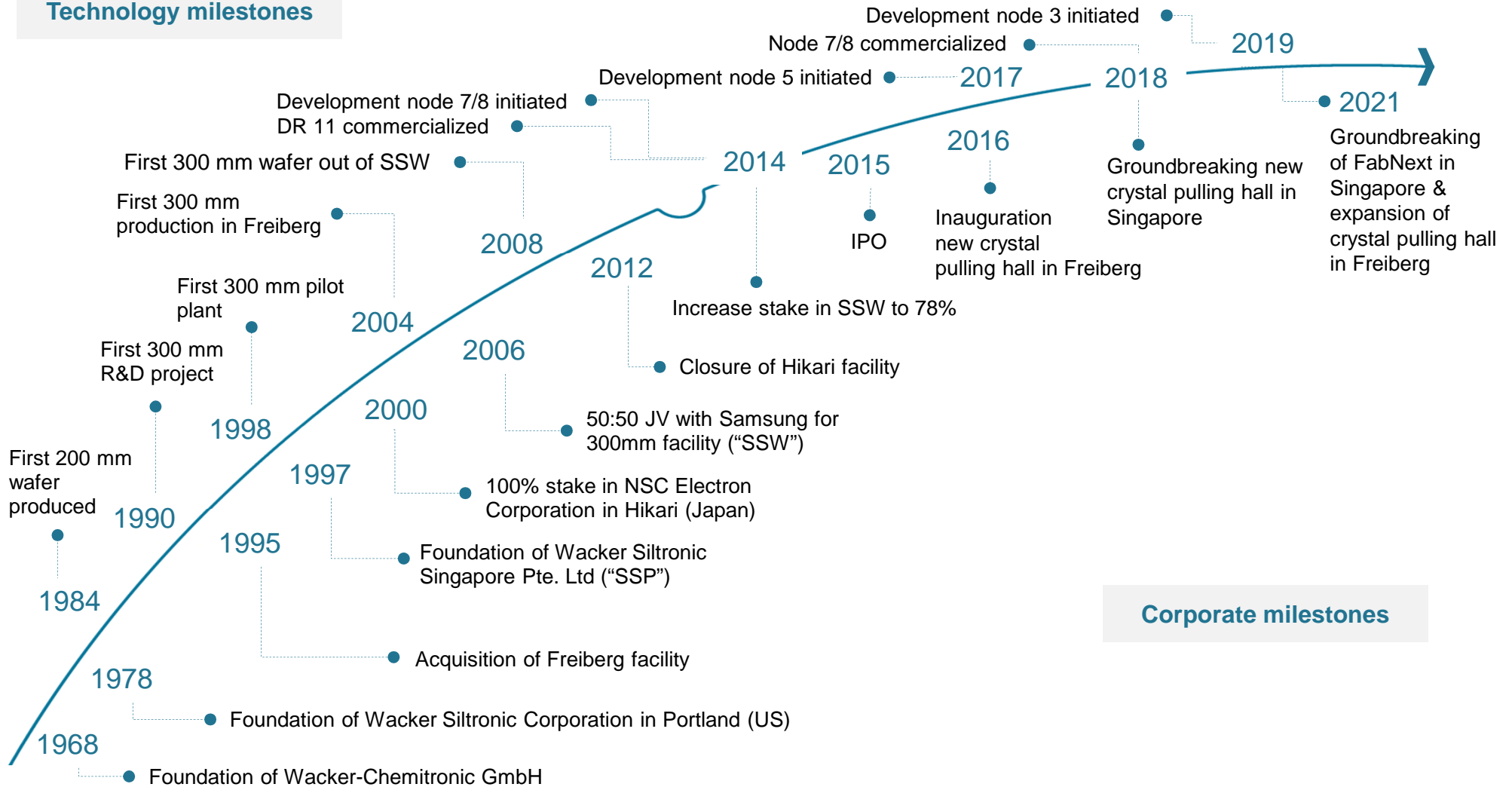
- ▶ Sales: EUR 1,805.3 million
- ▶ EBITDA: EUR 671.6 million
- ▶ EBITDA margin: 37.2%
- ▶ Net cashflow: EUR -395.4 million
- ▶ Net financial assets: EUR 373.6 million



= Production sites, Headquarter in Munich

More than 50 years of experience in the semiconductor industry

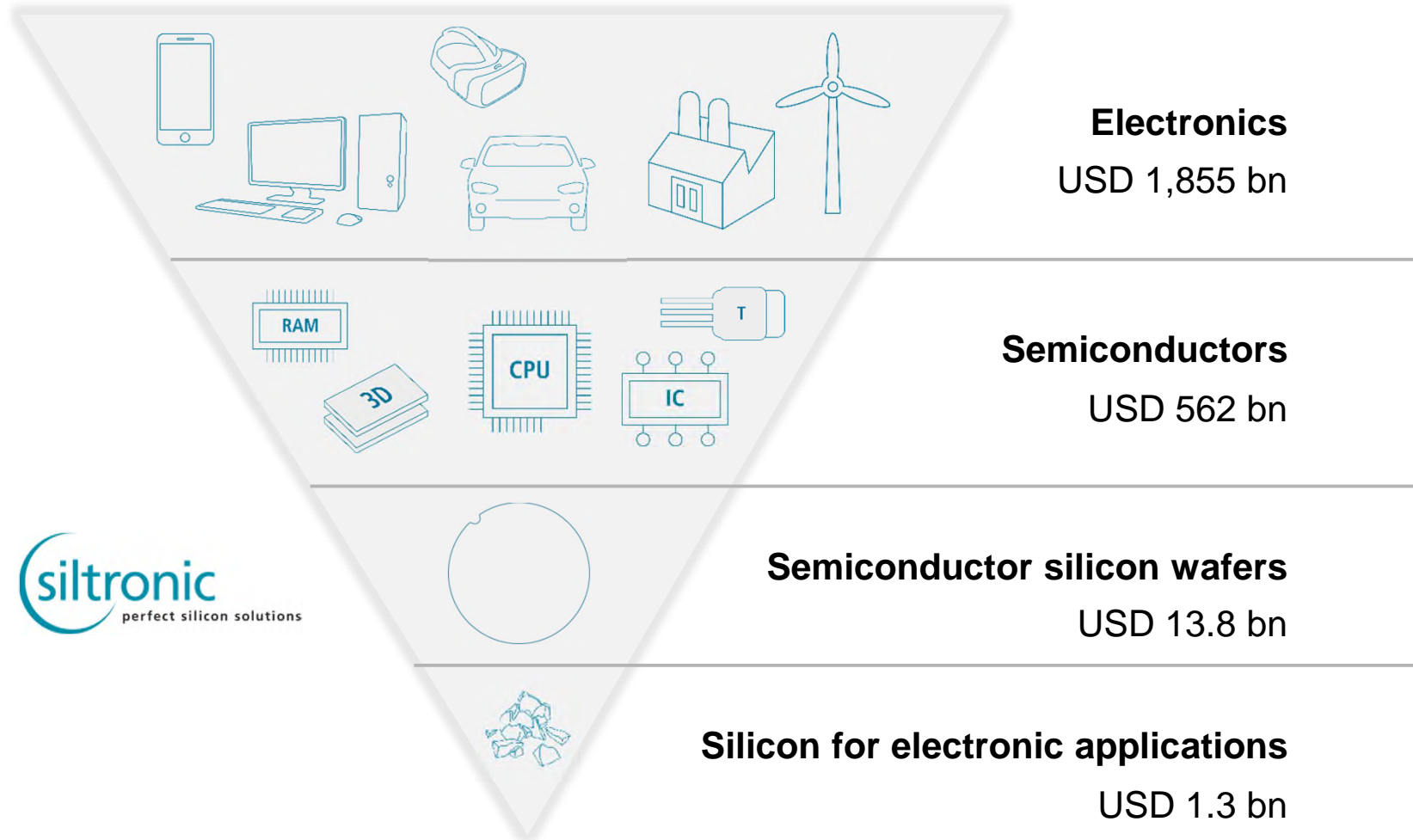
Technology milestones



Corporate milestones

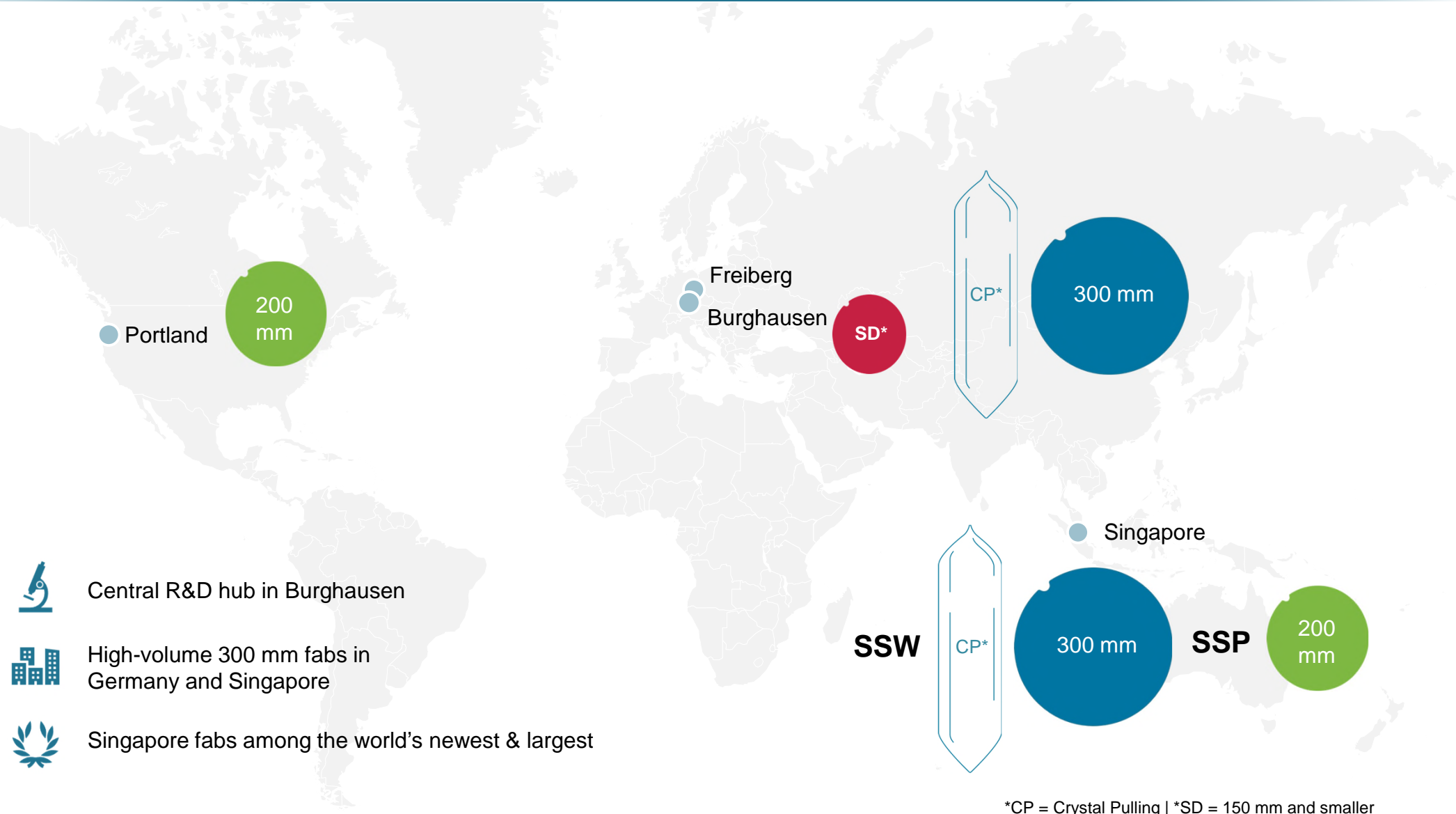
Electronics value chain continued to grow in 2022

Increasing demand for electronic devices and new applications drive semiconductor growth, which in turn fuels silicon demand



Sources: TechInsights, WSTS (Si based), SEMI SMG, Siltronic Marketing

International manufacturing network supports strong market position and business focus



Top technology position complemented with a high level of quality

A leading position in wafer technology

- ▶ Commercialization of 3 nm node started in 2022
- ▶ Development of 2 nm node started in 2021 (commercialization expected to start in 2024)
- ▶ Concurrently optimizing on 50+ wafer parameters of each design rule
- ▶ Single wafer traceability for 300 mm
- ▶ Standardized processes across sites enabling “copy exactly” at product level

R&D expenditure, in EUR mn (% of sales)



>400 R&D employees worldwide



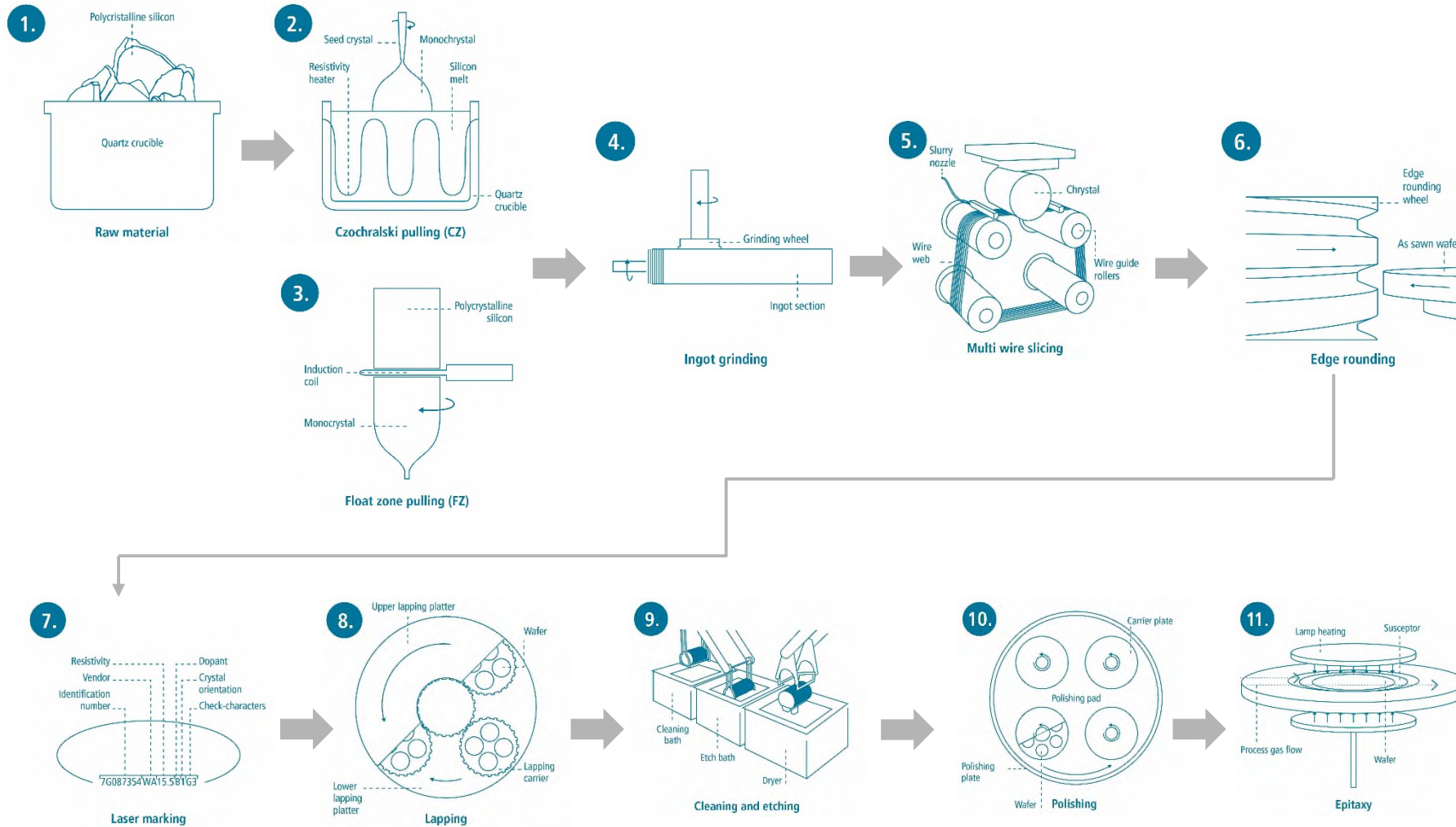
Approximately 1,890 pending and active patents in almost 350 patent families*

Quality awards from several top semiconductor customers received over the years



*as of December 31, 2022

Crystal growing and wafer production process



About the author

Georg Raming

- ▶ Electrical Engineer, PHD in simulation of electrothermal processes
- ▶ Six Sigma Black Belt
- ▶ Development of Silicon crystal growth processes at Siltronic AG, Freiberg (Germany), a semiconductor wafer manufacturer
- ▶ Responsible for support of JMP Software within Siltronic AG for ~ 500 users



source: Siltronic AG

Data cockpit:

Ways to extend a master table on click with additional data

Problem / Task

- ▶ One table (Data Cockpit) contains an overview on products or batches etc.
- ▶ Overview graphs to assess performance and other parameter
- ▶ Additional tables are generated based on content and selection of main table
- ▶ Additional Columns / Values are added to main table
- ▶ Links provided to drill down for more detail data

▶ **JMP Data table is a great GUI**

Solution steps

- ▶ Database Queries (new sql query)
- ▶ JMP Data table for overview
- ▶ Event handler to act on click
- ▶ Table scripts for
 - ▶ starting platforms
 - ▶ adding columns
 - ▶ generate detail tables
 - ▶ one click execute all

▶ **JSL for detail implementation**

Database

Simulated by sample Table “Anodic Bond”

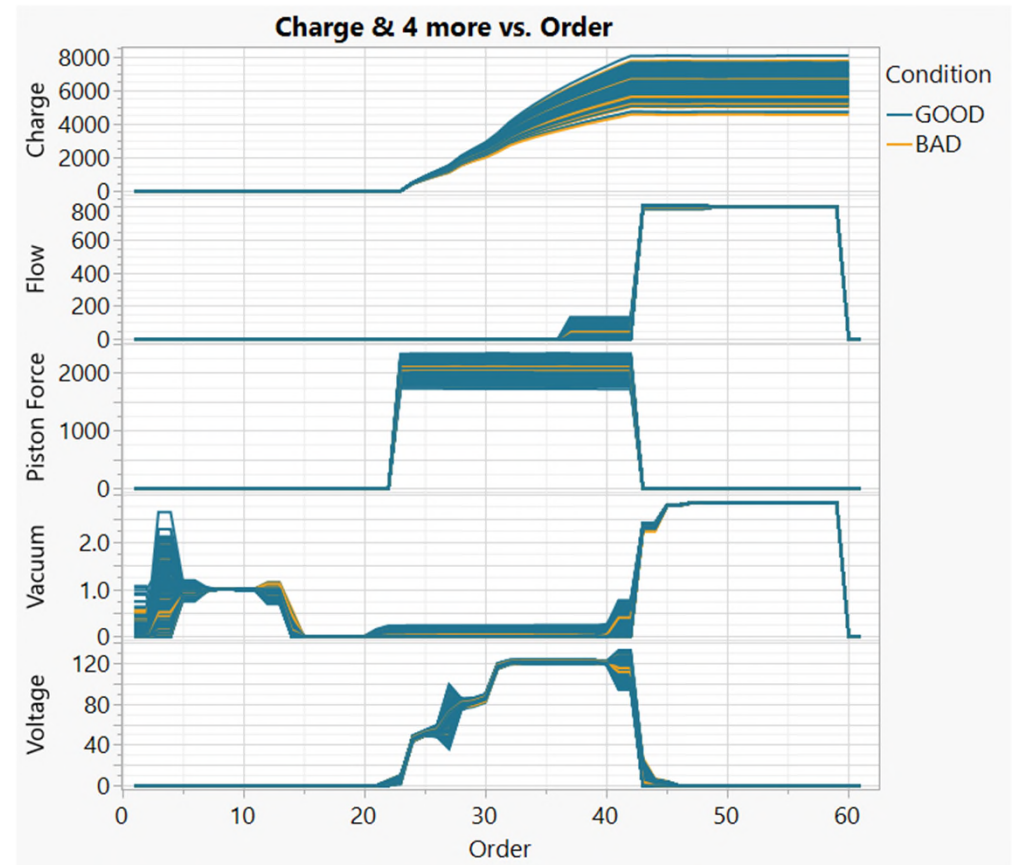
In real application data comes from company database(s)

- ▶ Cockpit / Summary is compiled by query on many different tables
- ▶ Additional data is added from same or other tables
- ▶ Other sources available for JMP could be used as well (files, www, images, video ...)

In this presentation a sample data table is used to simulate database

- ▶ table: Anodic Bond

▶ DB access similar to table access



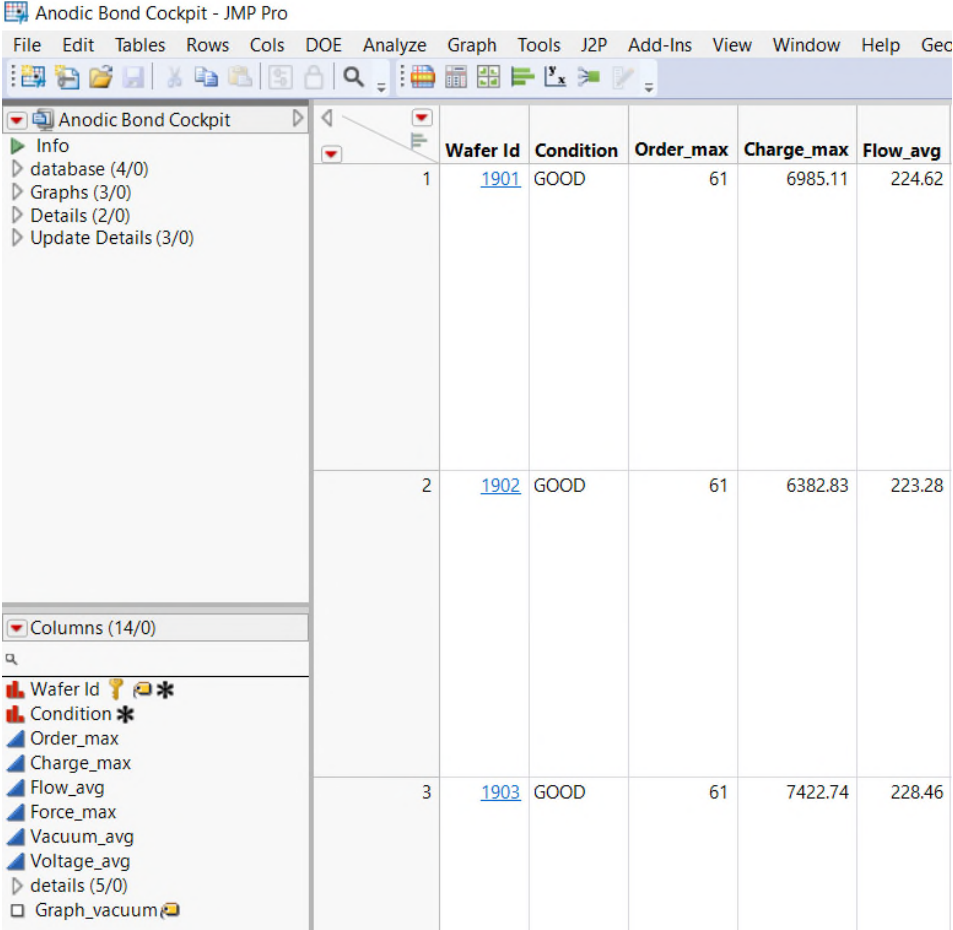
▶ 5 variables along order for each ID

Data Cockpit

Summary table with update (from DB) function

Data Table as User GUI

- ▶ contains ID and summary data
- ▶ table scripts to
 - ▶ update data
 - ▶ show evaluations
 - ▶ add details
 - ▶ add tables
- ▶ link on Wafer Id for detail drill down
- ▶ detail columns are grouped
- ▶ column with graph elements



Anodic Bond Cockpit - JMP Pro

Wafer Id	Condition	Order_max	Charge_max	Flow_avg
1901	GOOD	61	6985.11	224.62
1902	GOOD	61	6382.83	223.28
1903	GOOD	61	7422.74	228.46

Columns (14/0)

- Wafer Id
- Condition *
- Order_max
- Charge_max
- Flow_avg
- Force_max
- Vacuum_avg
- Voltage_avg
- details (5/0)
- Graph_vacuum

Data Cockpit

Detailed view of features

The screenshot displays the JMP Pro Data Cockpit interface for an 'Anodic Bond Cockpit'. The main data table shows columns for various parameters across different wafer IDs. The interface includes a sidebar with a tree view of data objects, a 'Columns' list, and a 'Rows' list. A 'Column Switcher' window is open, showing a list of columns to be displayed in the main graph. The main graph area contains several plots: 'Charge vs. Order' and four 'Vacuum vs. Order' plots. Red callout arrows highlight specific features: 'Table scripts' points to the sidebar tree; 'Event handler' points to a script in the tree; 'Symbolic link to details' points to a link in the 'Columns' list; 'Detail columns' points to a column in the 'Columns' list; 'Drill down for details' points to the 'Charge vs. Order' graph; and 'Detail graphs' points to the 'Vacuum vs. Order' graphs.

Wafer Id	Condition	Order_max	Charge_max	Flow_avg	Force_max	Vacuum_avg	Voltage_avg	charge43	flow40	force30	vacuum3	voltage27	
1	1901	GOOD	61	6985.11	224.62	2009.91	0.95	31.24	6972.58	19.74	2008.22	0.83	79.50
2	1902	GOOD	61	6382.83	223.28	2273.10	0.98	31.91	6379.98	0.00	2272.41	0.00	
3	1903	GOOD	61	6382.83	223.28	2273.10	0.98	31.91	6379.98	0.00	2272.41	0.00	
4	1904	GOOD	61	6382.83	223.28	2273.10	0.98	31.91	6379.98	0.00	2272.41	0.00	

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